



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **NAKATA, Yoshihiro et al.**

Group Art Unit: 1771

Serial No.: 10/807,174

Examiner: VO, Hai

Filed: **March 24, 2004**

**P.T.O. Confirmation No.: 4205**

**FOR: SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,  
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW  
DIELECTRIC CONSTANT FILM**

**REQUEST FOR STATUS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: September 26, 2005

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on **March 24, 2004** in the U.S. Patent and Trademark Office  
and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit  
Account No. 01-2340.

Respectfully submitted,

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